

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant :** Yoshitsugu MORITA et al.

**Int. App. Serial No.:** PCT/JP2004/018548

**Group Art Unit:** Unknown

**Atty. No. :** 71,051-035

**Examiner:** Unknown

**Filed :** Herewith

**Title :** SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THEREOF

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**PRELIMINARY AMENDMENT**

**MAIL STOP PCT**

**Commissioner for Patents**

P.O. Box 1450

Alexandria, Virginia 22313-1450

Dear Sir:

In reference to the above-referenced patent application, please enter the following Preliminary Amendment and consider the accompanying remarks prior to examination on the merits. A complete listing of all claims pending in the application is included as required under 37 CFR § 1.121.